

LEENDERS et al. -- 10/823,772
Attorney Docket: 081-168-0308799

IN THE CLAIMS:

This listing of claims will replace all prior versions, and listings, of claims in the application:

1. (Currently amended) A projection system, comprising.
~~at least one~~ a projection device configured to receive a beam of radiation coming from a first object and to project the beam of radiation to a second object;
~~at least one~~ a sensor configured to measure a spatial orientation of the at least one projection device; and
a processing unit configured to communicate with the ~~at least one~~ sensor and with a positioning device, the positioning device configured to adjust the position of the projection device and at least one of the first object and the second object based on the measured spatial orientation of the ~~at least one~~ projection device.
2. (Currently amended) A projection system according to claim 1, wherein the processing unit is configured to communicate with a second positioning device configured to adjust the spatial orientation of the ~~at least one~~ projection device based on the measured spatial orientation of the ~~at least one~~ projection device.
3. (Currently amended) A projection system according to claim 1, wherein the positioning device is configured to adjust the position of at least one of the first object and the second object based on a residual error after adjusting the spatial orientation of the ~~at least one~~ projection device.
4. (Currently amended) A projection system according to claim 1, wherein the processing unit is configured to:
adjust the position of at least one of the first object and the second object based on the measured spatial orientation of the ~~at least one~~ projection device in a first frequency range;
and,
adjust the spatial orientation of the ~~at least one~~ projection device based on the measured spatial orientation of the ~~at least one~~ projection device in a second frequency range.

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5. (Currently amended) A projection system according to claim 1, wherein the ~~at least one~~ projection device comprises ~~at least one of~~ a mirror ~~[[and]]~~ or a lens.
6. (Currently amended) A projection system according to claim 1, wherein the ~~at least one~~ projection device is mounted on a mounting device configured to actuate the at least one projection device in ~~at least one~~ degree of freedom.
7. (Original) A projection system according to claim 1, wherein the beam of radiation is an extreme ultraviolet beam of radiation.
8. (Currently amended) A projection system according to claim 1, wherein the processing unit is configured to communicate with ~~at least one~~ a second sensor configured to determine a position of at least one of the first object and the second object.
9. (Original) A projection system according to claim 1, wherein the processing unit comprises an I/O-device, a micro-processor, and a memory device.
10. (Currently amended) A method for projecting a beam of radiation coming from a first object, and received by ~~at least one~~ a projection device, to a second object, the method comprising:
 - measuring a spatial orientation of the ~~at least one~~ projection device;
 - determining an orientation error in the spatial orientation of the ~~at least one~~ projection device;
 - computing a projection error of an image projected on the second object based on the orientation error in the spatial orientation of the ~~at least one~~ projection device; and
 - adjusting a position of the projection device and at least one of the first object and the second object to minimize a projection error.
11. (Currently amended) A method according to claim ~~[[12]]~~ 10, further comprising calibrating an alignment of the first object to the second object in at least one degree of freedom.
12. (Currently amended) A lithographic apparatus, comprising:
 - an illumination system configured to provide a beam of radiation,

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a support configured to support a patterning device, the patterning device configured to impart the beam with a pattern in its cross-section;

a substrate table configured to hold a substrate;

a projection system configured to project the patterned beam onto a target portion of the substrate, the projection system comprising:

~~at least one~~ a projection device configured to receive a beam of radiation coming from a first object and project the beam of radiation to a second object;

~~at least one~~ a sensor configured to measure a spatial orientation of the ~~at least one~~ projection device; and

a processing unit configured to communicate with the ~~at least one~~ sensor and with a positioning device, the positioning device configured to adjust the position of the projection device and at least one of the first object and the second object based on the measured spatial orientation of the ~~at least one~~ projection device

13. (Currently amended) An apparatus according to claim 12, wherein the processing unit is configured to communicate with a second positioning device configured to adjust the spatial orientation of the ~~at least one~~ projection device based on the measured spatial orientation of the ~~at least one~~ projection device.

14. (Currently amended) An apparatus according to claim 12, wherein the positioning device is configured to adjust the position of at least one of the first object and the second object based on a residual error after adjusting the spatial orientation of the ~~at least one~~ projection device.

15. (Currently amended) An apparatus according to claim 12, wherein the processing unit is configured to:

adjust the position of at least one of the first object and the second object based on the measured spatial orientation of the ~~at least one~~ projection device in a first frequency range; and

adjust the spatial orientation of the ~~at least one~~ projection device based on the measured spatial orientation of the ~~at least one~~ projection device in a second frequency range.

16. (Currently amended) An apparatus according to claim 12, wherein the ~~at least one~~ projection device comprises ~~at least one of~~ a mirror ~~[[and]]~~ or a lens.

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17. (Currently amended) An apparatus according to claim 12, wherein the ~~at least one~~ projection device is mounted on a mounting device configured to actuate the ~~at least one~~ projection device in at least one degree of freedom.
18. (Original) An apparatus according to claim 12, wherein the beam of radiation is an extreme ultraviolet beam of radiation.
19. (Currently amended) An apparatus according to claim 12, wherein the processing unit is configured to communicate with ~~at least one~~ a second sensor configured to determine a position of at least one of the first object and the second object.
20. (Original) An apparatus according to claim 12, wherein the processing unit comprises an I/O-device, a micro-processor, and a memory device.
21. (Currently amended) A device manufacturing method, comprising:
~~providing a substrate at least partially covered by a layer of radiation sensitive material; and~~
projecting a beam of radiation coming from a patterning device, and received by at least one projection device, to ~~[[the]]~~ a substrate at least partially covered by a layer of radiation sensitive material, the projecting comprising:
measuring a spatial orientation of the ~~at least one~~ projection device;
determining an orientation error in the spatial orientation of the ~~at least one~~ projection device;
computing a projection error of an image projected on the substrate based on the orientation error in the spatial orientation of the at least one projection device; and
adjusting a position of the projection device and at least one of the patterning device and the substrate to minimize a projection error.
22. (Original) A method according to claim 21, further comprising:
calibrating an alignment of the patterning device to the substrate in at least one degree of freedom.